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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO. CONFIRMATION I		
10/043,274	01/14/2002	Boris Goldberg	4071 USA/PDC/WF/OR	. 4731	
32588	7590 05/07/2003				
APPLIED MATERIALS, INC.			EXAMINER		
2881 SCOTT BLVD. M/S 2061 SANTA CLARA, CA 95050			CHERRY, EUNCHA P		
			ART UNIT	PAPER NUMBER	
·			2872		
			DATE MAIL ED: 05/07/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

PTO-326 (Re		ction Summary		Part of Paper No. 7					
2) Notice 3) Inform U.S. Patent and Tr	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s)	4)		ry (PTO-413) Paper No(s Patent Application (PTO-					
Attachment	c(s)	_							
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l <u> </u>	see the attached detailed Office action for a list		-		annlication)				
	application from the International Bureau (PCT Rule 17.2(a)).								
	Copies of the certified copies of the priority documents have been received in Application No  3. Copies of the certified copies of the priority documents have been received in this National Stage								
	<ol> <li>Certified copies of the priority documents have been received.</li> <li>Certified copies of the priority documents have been received in Application No</li> </ol>								
	a) All b) Some * c) None of:								
· ·	13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).								
		n priority under 2	51100 £440/	a) (d) or (f)					
12) The oath or declaration is objected to by the Examiner.  Priority under 35 U.S.C. §§ 119 and 120									
12) 🗆 🗆	If approved, corrected drawings are required in reply to this Office action.								
11)[_]				oved by the Examiner	•				
44)[7] -	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.								
10)∐ 1	10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.								
1 '-	The specification is objected to by the Examine								
'	on Papers								
, , , , , , , , , , , , , , , , , , , ,	8) Claim(s) are subject to restriction and/or election requirement.								
7)	7) Claim(s) is/are objected to.								
6)⊠	⊠ Claim(s) <u>1-33</u> is/are rejected.								
5)	Claim(s) is/are-allowed.								
	4a) Of the above claim(s) is/are withdrawn from consideration.								
4)🖂	Claim(s) 1-33 is/are pending in the applicatio	n.							
Dispositi	closed in accordance with the practice under on of Claims	Ex parte Quayle,	1800 U.D. 11,	400 U.G. 210.					
3)□	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.								
2a) <u></u>	This action is <b>FINAL</b> . 2b)⊠ Ti	his action is non-fi	nal.						
1) 🗌	Responsive to communication(s) filed on	·	•						
- Exten after: - If the - If NO - Failur - Any re	MAILING DATE OF THIS COMMUNICATION. Issions of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a repperiod for reply is specified above, the maximum statutory period to reply within the set or extended period for reply will, by statutely received by the Office later than three months after the mailing dispatent term adjustment. See 37 CFR 1.704(b).	ly within the statutory mir will apply and will expire e, cause the application t	nimum of thirty (30) da SIX (6) MONTHS fron to become ABANDON	ys will be considered timely. In the mailing date of this come ED (35 U.S.C. § 133).	nmunication.				
A SH	ORTENED STATUTORY PERIOD FOR REPL	Y IS SET TO EXI	PIRE <u>3</u> MONTH	(S) FROM					
Period fo	The MAILING DATE of this communication ap r Reply	pears on the cove	r sheet with the	correspondence add	ress				
		EUNCHA P. CHI	<del> </del>	2872					
	Office Action Summary	Examiner		Art Unit					
		10/043,274	•	GOLDBERG ET AL.					
1		Application No.		Applicant(s)	<u>~~</u> ,				

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### DETAILED ACTION

## Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 1-3, 6, 7, 10-17, 19-25, 27-29 and 31-33 are rejected under 35 U.S.C. 102(e) as being anticipated by Flint.

Flint discloses a polygon scanning system (Fig. 2) comprising:

a polygon having a reflective facet (233);

rotation mechanism (240) for rotating the polygon;

first light source (212) for directing a first light beam to impinge on the facet at a first incident angle such that the first light beam is reflected by the facet to scan a first portion of a surface of a substrate (252 then to 270) during a first time interval when the rotation mechanism is rotating the polygon (see abstract lines 1-3);

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a second light source (211) for directing a second light beam to impinge on the facet at a second incident angle such that the second light beam is reflected by the facet to scan a second portion of the surface of the substrate during a second time interval subsequent to the first time interval when the rotation mechanism is rotating the polygon (see abstract lines The first and second light sources comprise a single light beam generator for generating an original light beam (200) and a first beam splitter (210) for splitting the original light beam into the first and second light beams. A mirror (227) for directing the second light beam to impinge on the facet (234). The first and second light sources comprise a single light beam generator for generating an original light beam and a diffraction grating for diffracting the original light beam into the first and second light beams (inherent from column 11, lines 3-5). The diffraction grating is for diffracting the original light beam into N light beams (at least two by column 11, lines 3-5), including the first and second light beams, to impinge on the facet at an Nth incident angle such that the Nth light beam is reflected by the facet to scan an Nth portion of the surface of the substrate during an Nth time interval when the rotation mechanism is rotating the polygon. The system further comprising an optical system (260) disposed between the facet

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and the substrate for focusing the first and second light beams. The first and second light sources provide laser lights, the original light source is a laser light source (column 10, lines 20-23). The first light source is for providing laser light at a first wavelength, and the second light source is for providing laser light at a second wavelength different from the first wavelength (column 10, lines 36-37, "approximately equal" therefore, there is a difference between the lights). One light of the plurality of light beams impinge on the facet at an incident angle different than the incident angles of the other light beams (see 211 and 212), and each light beam is reflected by the facet to scan a respective portion of a surface of a substrate during a respective time interval when the rotation mechanism is rotating the polygon (see 272, 274); wherein the facet has a total surface area, and each of the plurality of light beams is reflected onto the substrate surface using a respective portion of the facet surface; wherein the sum of the respective portions of the facet surface used to reflect the light beams is greater than 90 percent of the total surface area (inherent). The first portion of the surface of the substrate is the same as the second portion of the surface of the substrate (1st and 2nd portions are not clearly define in the claims, therefore, the scan lines on 270 met the languages). The system

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further comprises a movable stage (by 254) for supporting the substrate and moving the substrate relative to the polygon.

25. The system of claim 24, wherein the stage is for moving the substrate such that the first portion (272) of the surface of the substrate is different than the second portion (274) of the surface of the substrate of the substrate are different from each other.

# Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 8 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Flint in view of Fantuzzo et al.

Flint discloses the claimed invention as set forth above except that an acousto-optic deflector is used to deflect the original light beam to impinge on the facet at the first and second incident angles at the first and second time intervals, respectively. Fantuzzo et al discloses an acousto-optic

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deflector that is used to deflect the original light beam to impinge on the facet at the first and second incident angles at the first and second time intervals (Fig. 2 and column 5, lines 36-51). It would have been obvious to one of ordinary skill in the art to use an acousto-optic deflector to deflect the original light into more than one, because the acousto-optic deflector can actually create more than one, further more than two light beams, which does not require additional beam splitter in order to get more than two lights.

5. Claims 4, 5, 18, 26 and 30 are rejected under 35 U.S.C. 103(a) as being unpatentable over Flint.

Flint discloses the claimed invention as set forth above except that there is an additional beam splitter for a third light beam. It would have been obvious to one of ordinary skill in the art to one more beam splitter to create more light beams, since it has been held that mere duplication of the essential working parts of a device involves only routine skill in the art, so that the clear and high quality image can be obtained.

St. Regis Paper Co. V. Bemis Co., 193 USPQ 8.

### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to EUNCHA P.

CHERRY whose telephone number is 703-305-0997. The examiner can normally be reached on M-F 6:30-4:00, alternate Fridays off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, CASSANDRA SPYROU can be reached on 703-308-1687. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

Euncha Cherry

Patent Examiner

May 1, 2003